



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 17, 2025

IGI Report Number

LG749533009

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **SQUARE EMERALD CUT**

Measurements **7.13 X 7.12 X 4.46 MM**

GRADING RESULTS

Carat Weight **2.09 CARATS**

Color Grade **D**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

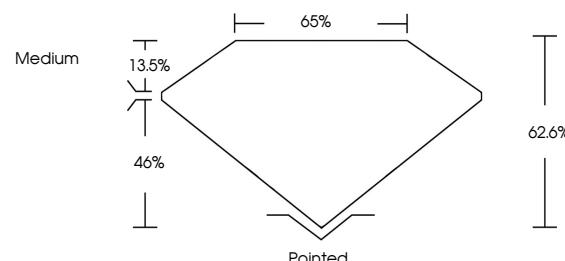
Fluorescence **NONE**

Inscription(s) **IGI LG749533009**

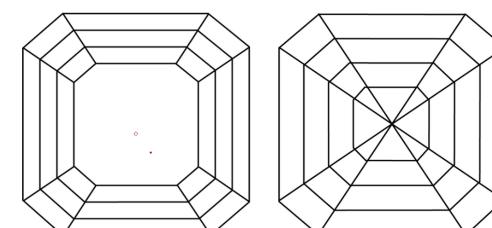
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG749533009
Report verification at igi.org

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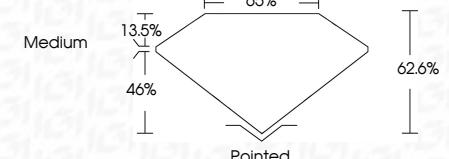
Carat Weight **2.09 CARATS**

D

Color Grade **VVS 2**



Sample Image Used



ADDITIONAL GRADING INFORMATION

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Symmetry **EXCELLENT**

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November 17, 2025	IGI Report No. LG749533009
	SQUARE EMERALD CUT
	7.13 X 7.12 X 4.46 MM
Carat Weight	2.09 CARATS
Color Grade	D
Clarity Grade	VVS 2
Depth	62.6%
Table Grade	65%
Culet	Medium
Polish	Pointed
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG749533009

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa